

1/14

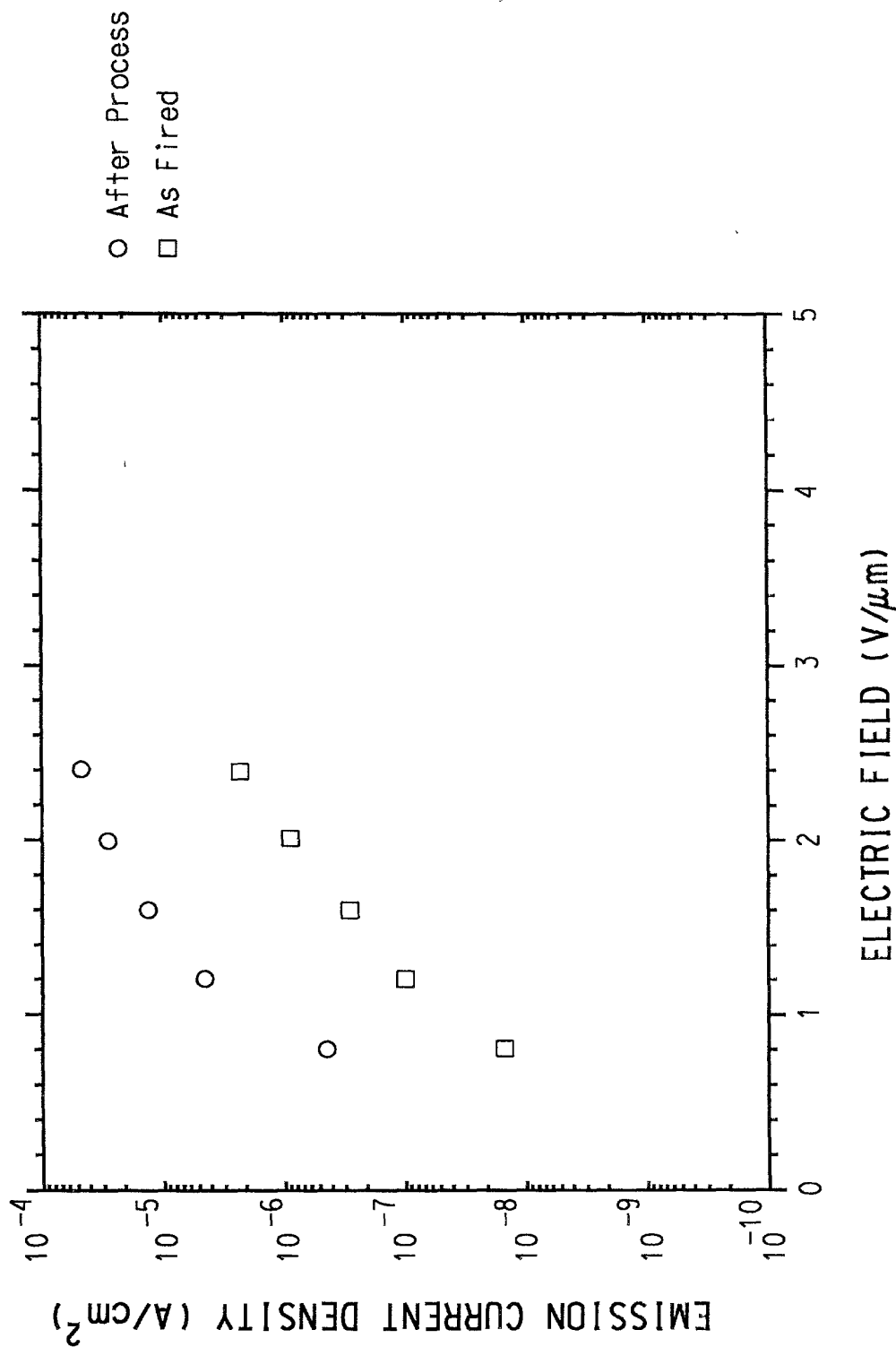


FIG. 1

202010" 61228850

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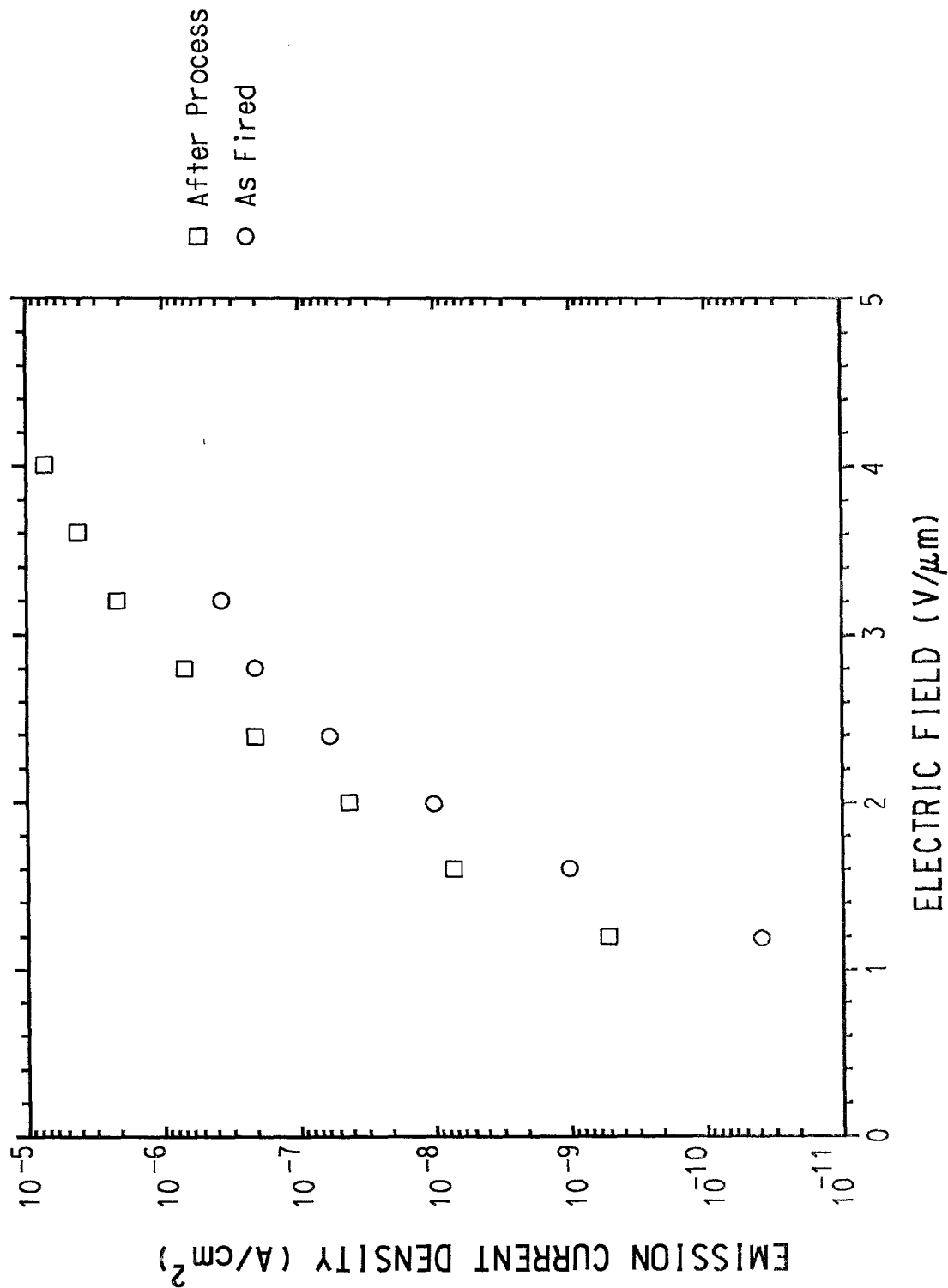


FIG. 2

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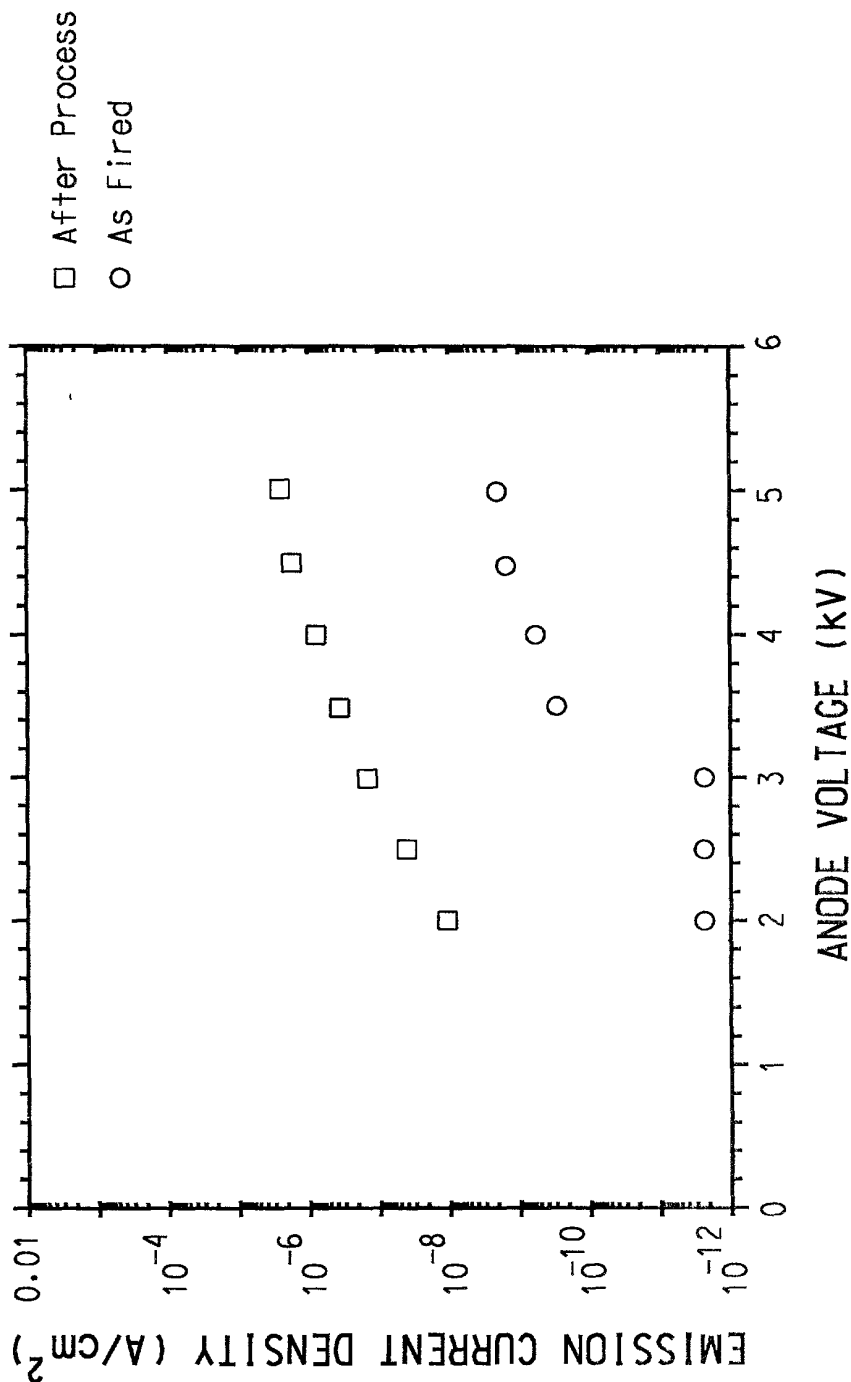


FIG. 3

202010" 67428860

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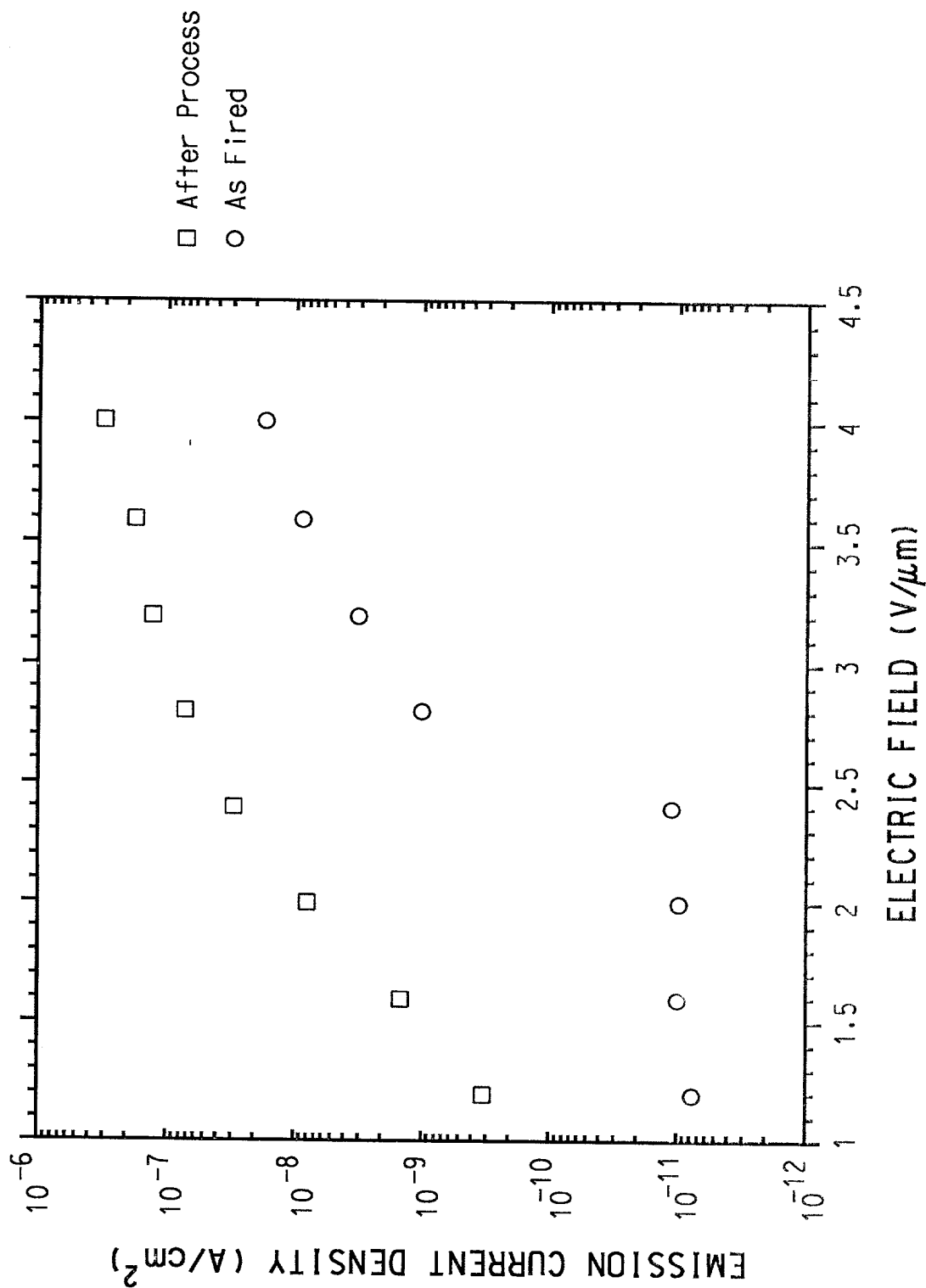
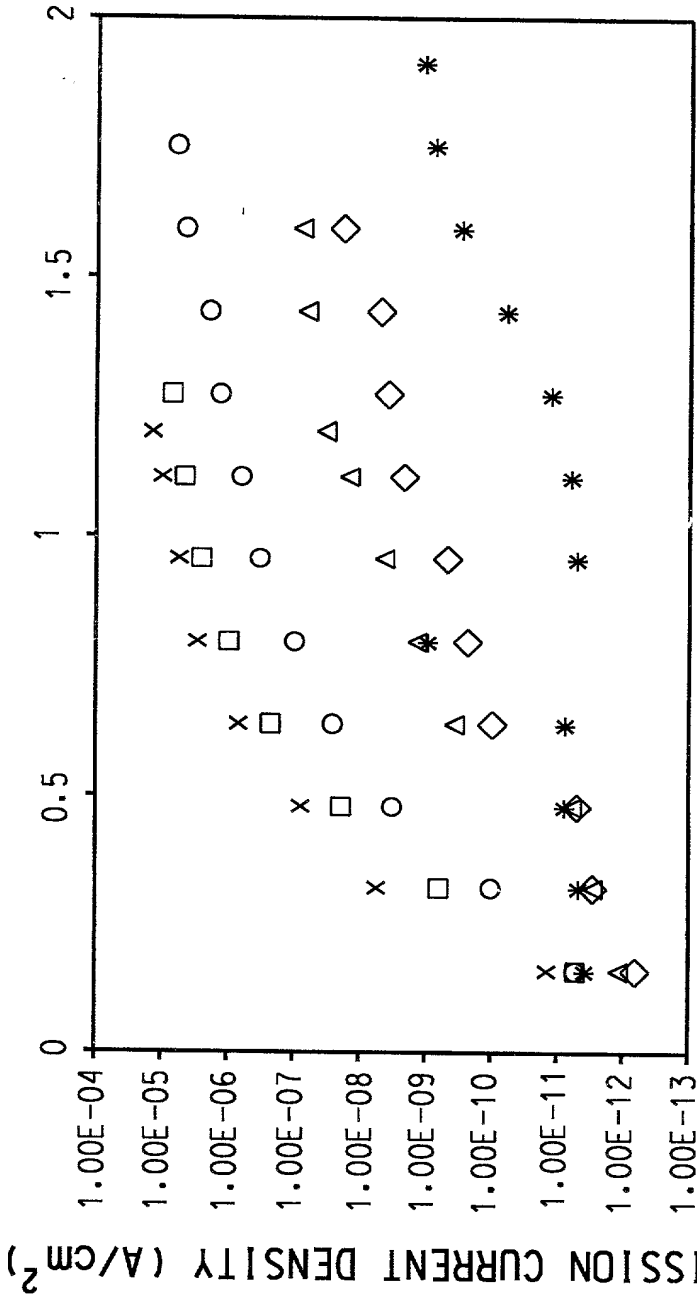


FIG. 4

202010" 6T 28860

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- ◇ Example 9 - As fired
- Example 9 - After process
- △ Example 10 - As fired
- x Example 10 - After process
- \* Example 11 - As fired
- o Example 11 - After process

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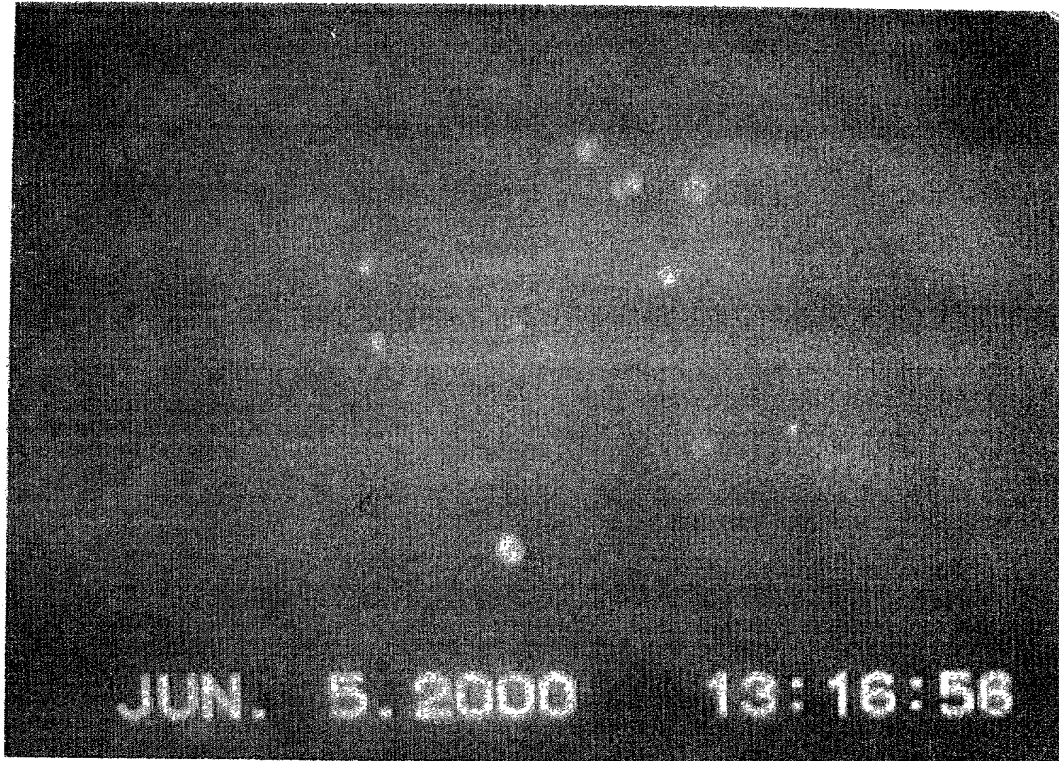


FIG. 6a

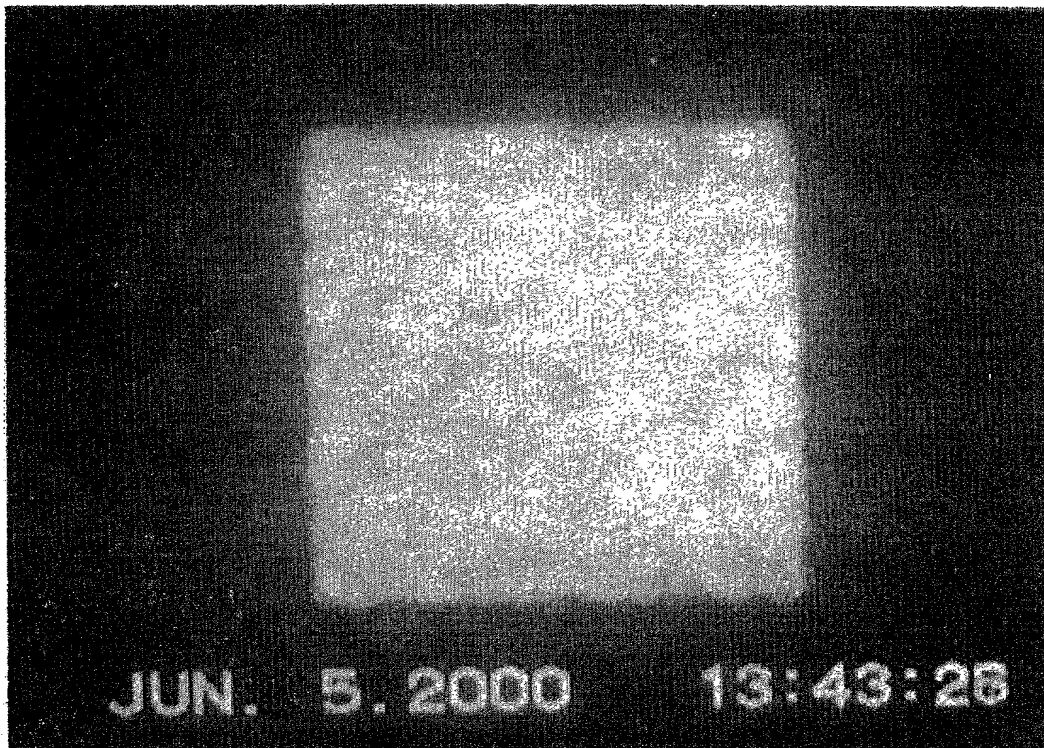


FIG. 6b

09882719-010202

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FIG. 6c

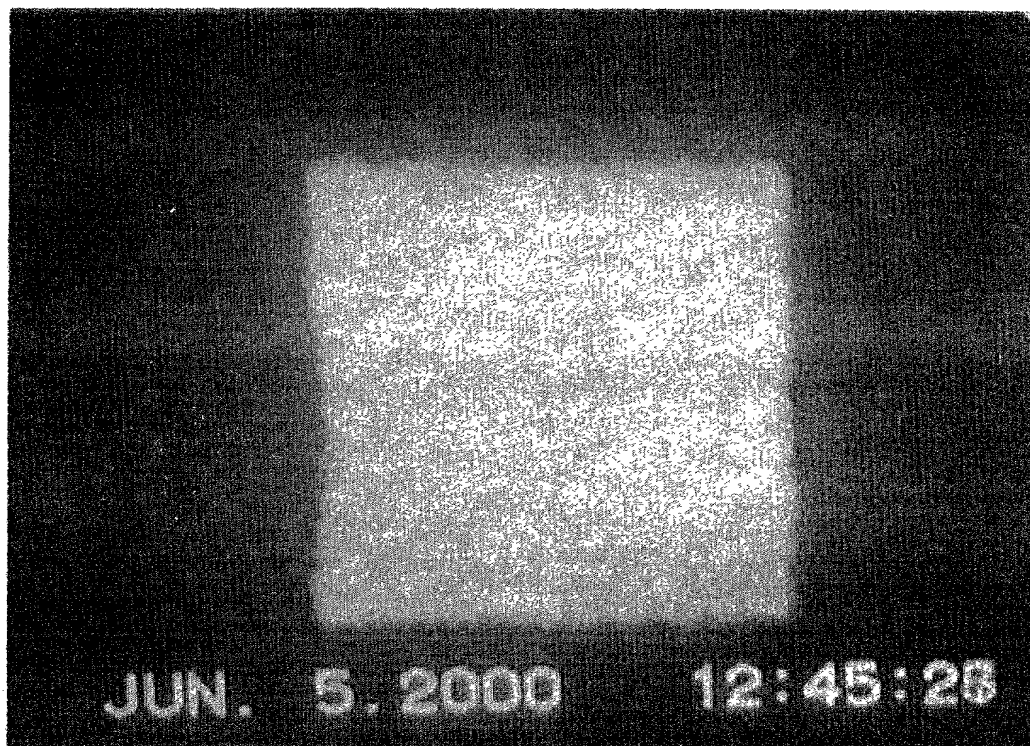


FIG. 6d

09882719-010202



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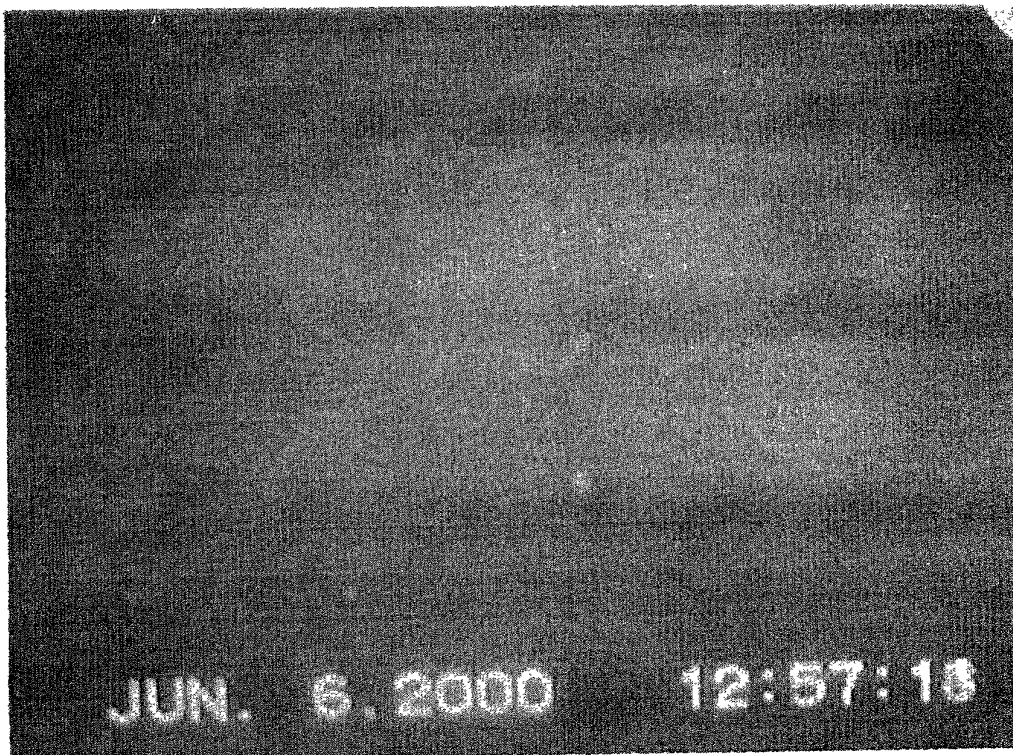


FIG. 6e

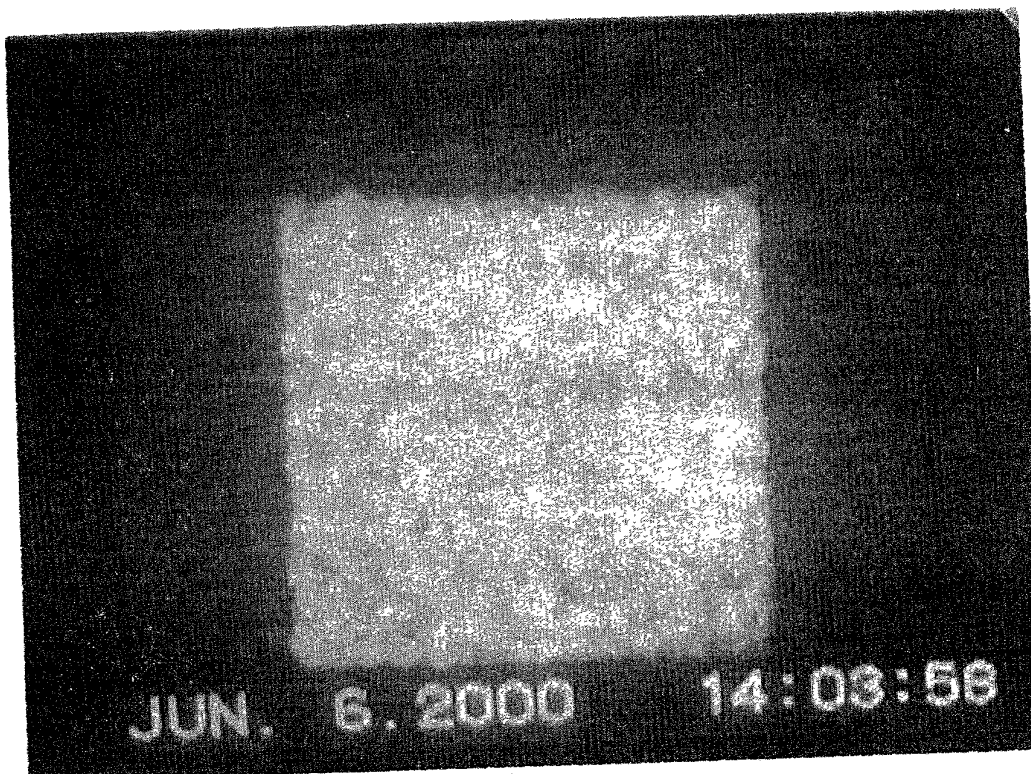
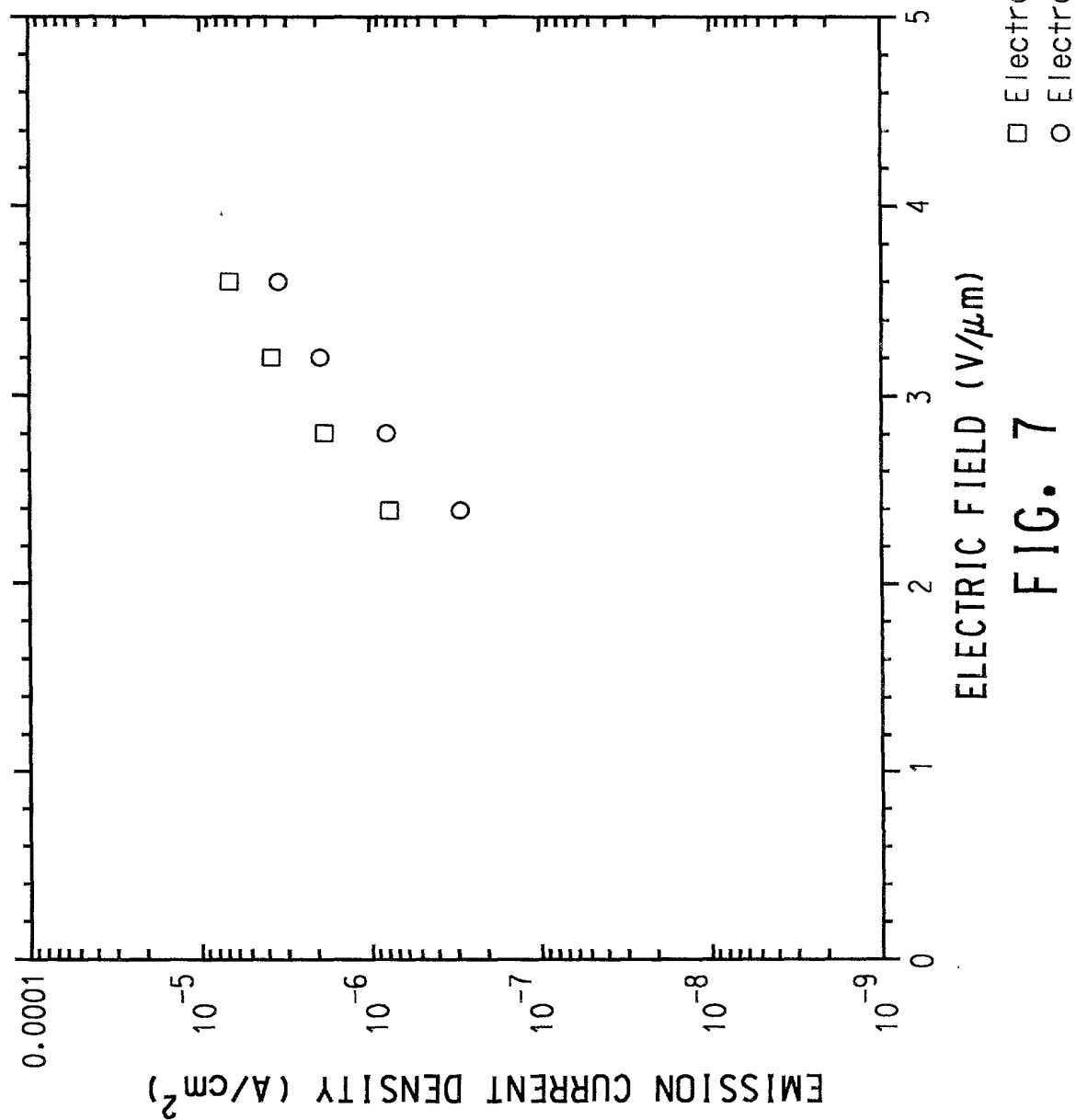


FIG. 6f

2022070" 5F288650



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FIG. 8a

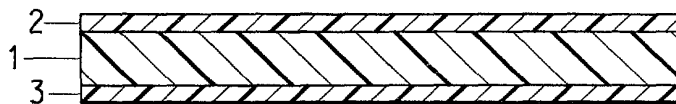


FIG. 8b

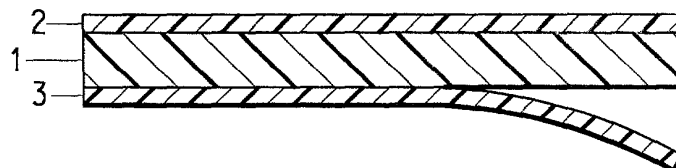


FIG. 8c

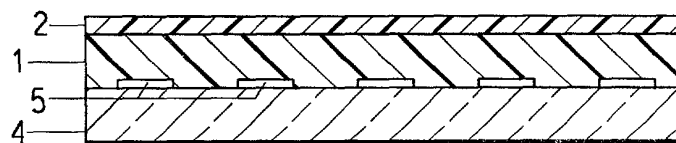


FIG. 8d

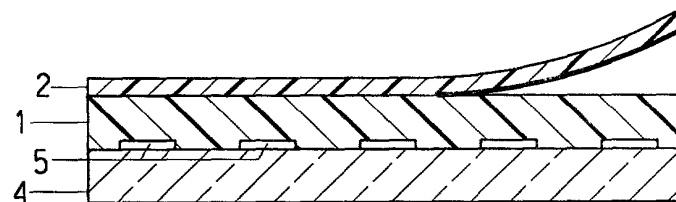


FIG. 8e

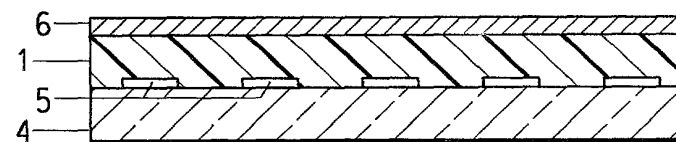


FIG. 8e



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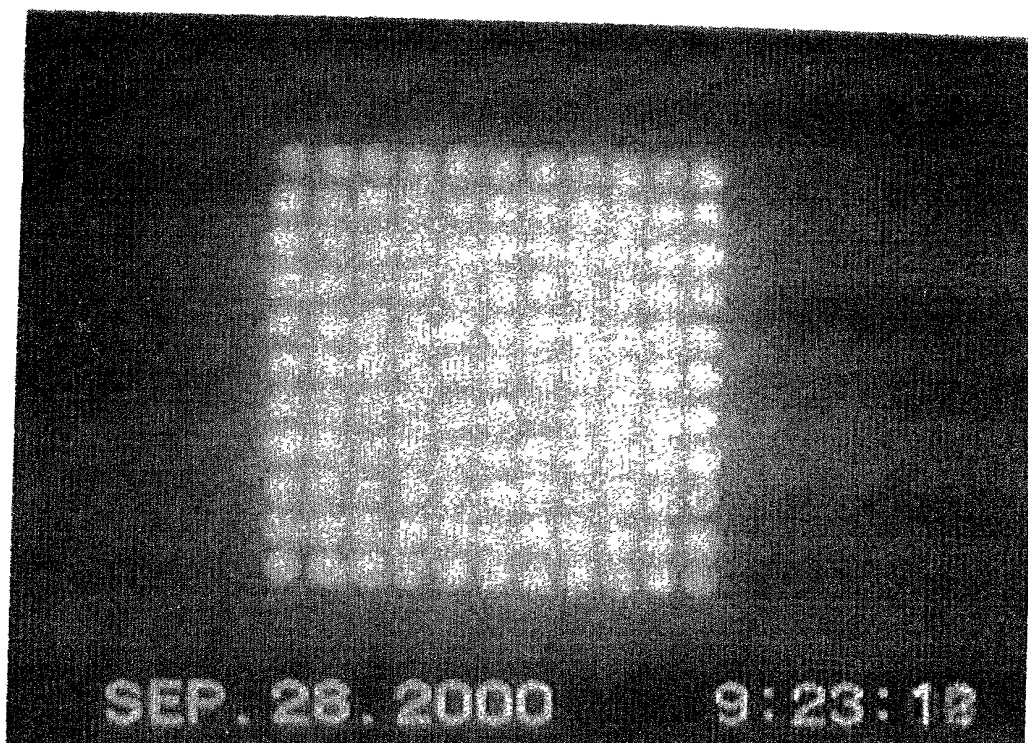


FIG. 9a

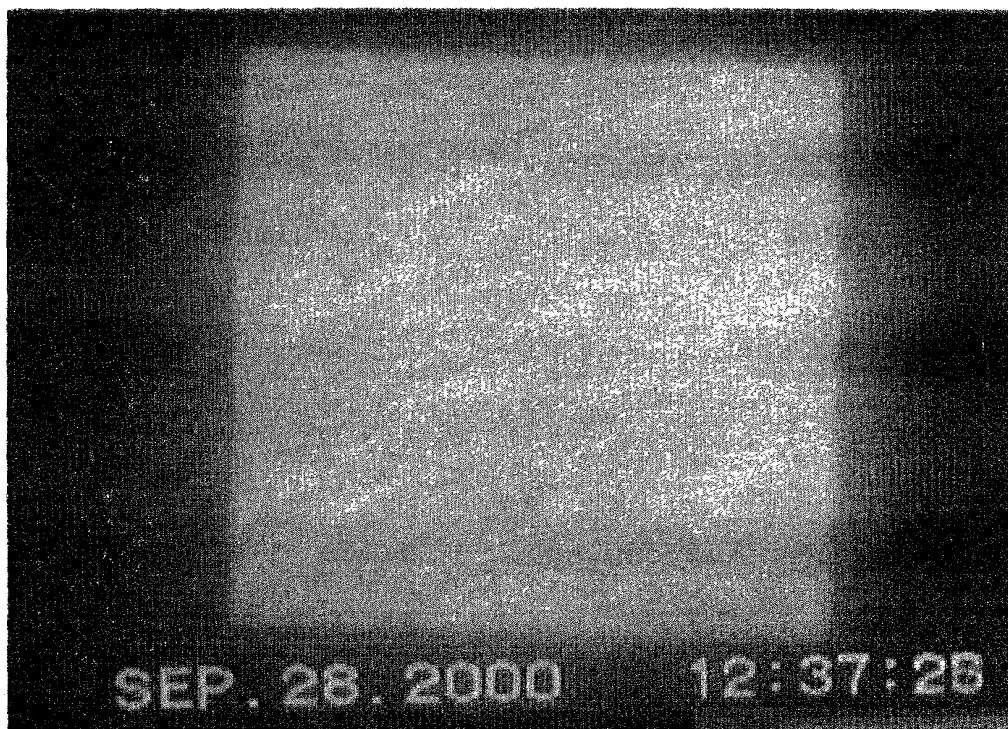


FIG. 9b

202070" 6T 228860

Docket No: CL-1673  
Title: Process for Improving The Emission Of Electron Field Emitters  
Inventor: Robert Joseph Bouchard, et. al.  
Appl. No.: 09/682,719  
E.I. DuPont de Nemours

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FIG. 10

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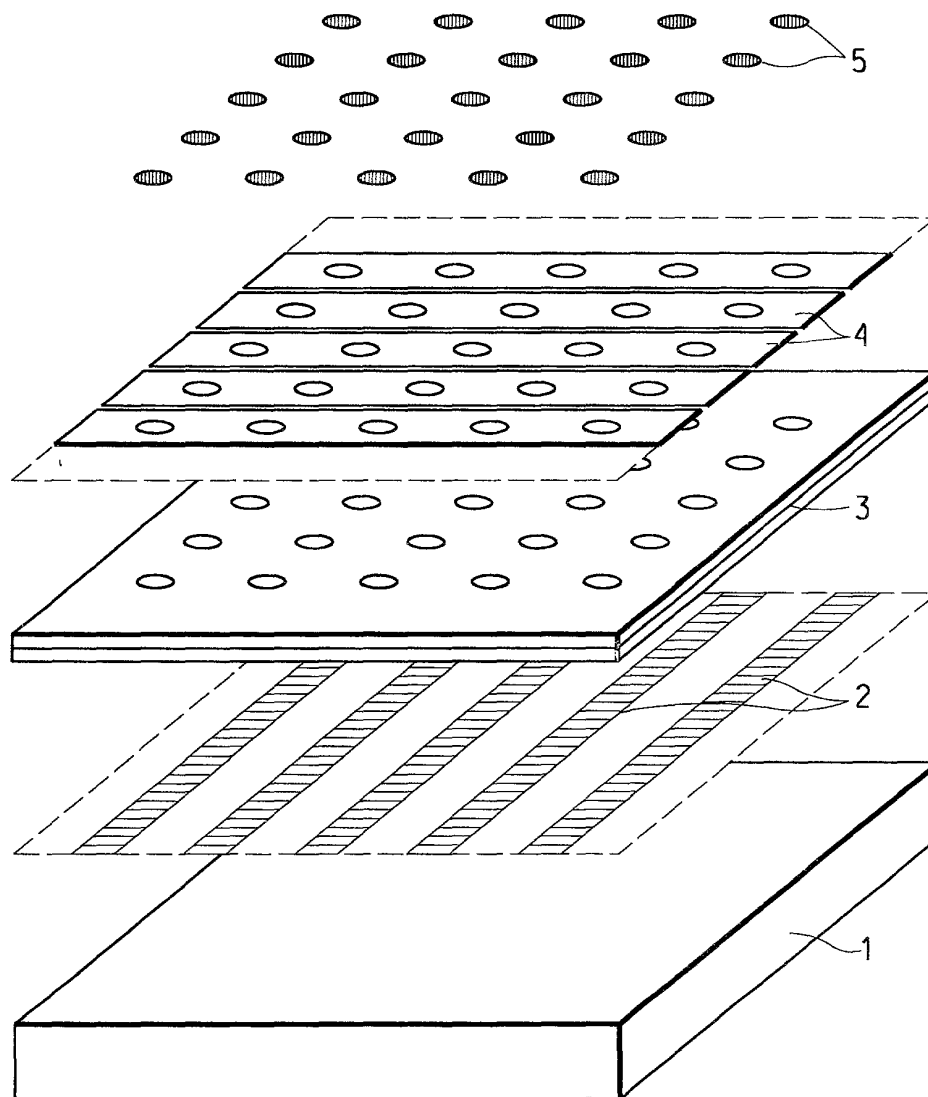


FIG. 11a

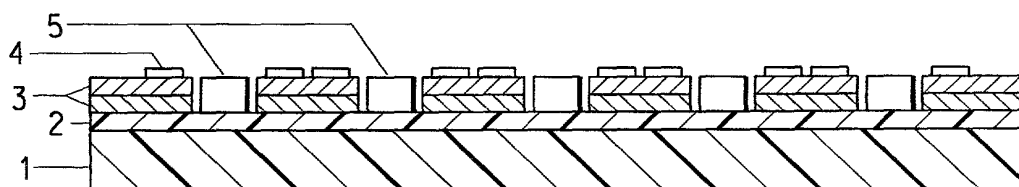


FIG. 11b

09882719-010200

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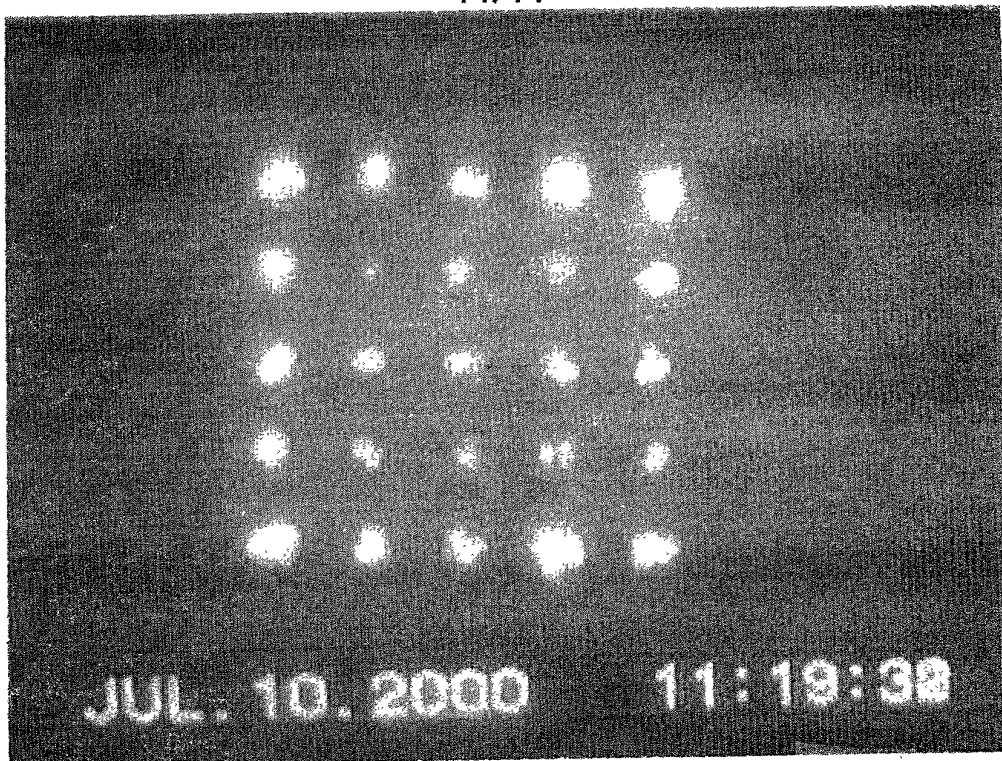


FIG. 12a

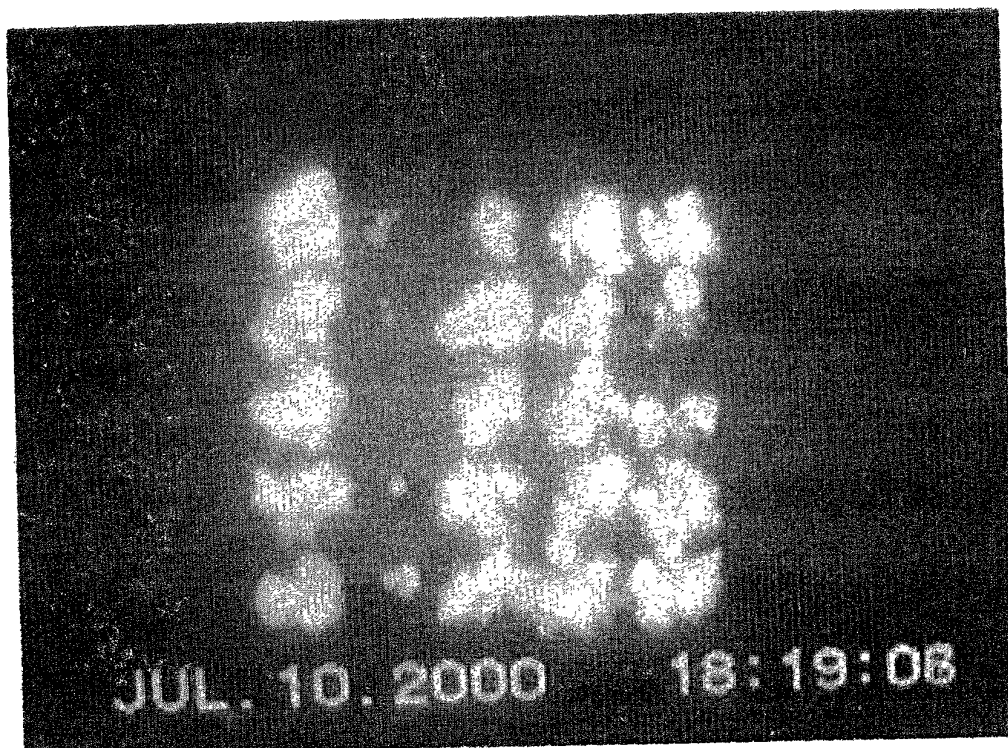


FIG. 12b

202070" 6T/28260